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**BOX AF**

AF/2800

**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 2813**

**PATENT**

Customer No. 22,852

Attorney Docket No. 08244.0032

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Sung-chan PARK et al.

Application No.: 09/998,303

Filed: December 3, 2001

For: METHOD FOR FORMING  
CONTACT HOLD AND SPACER  
OF SEMICONDUCTOR DEVICE

) Group Art Unit: 2813

) Examiner: T. Nguyen

# 9  
Amend  
B  
8/21/03  
afg  
9/26/03  
Moussil

**Mail Stop AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

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AUG 18 2003  
TC 2800 MAIL ROOM

**AMENDMENT AFTER FINAL**

In reply to the Final Office Action of May 19, 2003, and pursuant to 37 C.F.R.

§ 1.116, Applicants propose that this application be amended as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.

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